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Receipt

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Attn: OIPE

Seigo KODAMA et al.

Group Art Unit: 3729

Application No.: 10/564,815

Docket No.: 126601

Filed: February 14, 2006

For: MANAGING APPARATUS FOR MANAGING ASSISTING WORK TO ASSIST
SUBSTRATE-RELATED-WORK PERFORMING SYSTEM, AND MANAGING
PROGRAM FOR MANAGING ASSISTING WORK TO ASSIST SUBSTRATE-
RELATED-WORK PERFORMING SYSTEM

REQUEST FOR CORRECTION OF PALM RECORDS

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Attached is a photocopy of the original filing receipt on which errors have been corrected in red. These errors are being brought to the attention of the Patent and Trademark Office so that it may correct its records.

Respectfully submitted,

William P. Berridge
Registration No. 30,024

Julie M. Lake
Registration No. 51,156

WPB:JML/hjr

Date: July 18, 2006

OLIFF & BERRIDGE, PLC
P.O. Box 19928
Alexandria, Virginia 22320
Telephone: (703) 836-6400

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| 10/564,815 | 02/14/2006 | 3729 | 1030 | 126601 | 17 | 16 | 2 |

25944
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 P.O. BOX 19928
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JUN 07 2006

CONFIRMATION NO. 3390

FILING RECEIPT



OC000000019057042

Date Mailed: 06/02/2006

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Applicant(s)

Seigo Kodama, Yatomi-cho Ama-gun, JAPAN;
 Hiroyuki Haneda, Chita-shi, JAPAN;

Assignment for Published Patent Application
Fuji Machine MFG. Co., Ltd., Chiryu-shi, JAPAN

Power of Attorney: The patent practitioners associated with Customer Number 25944.

Domestic Priority data as claimed by applicant

This application is a 371 of PCT/JP04/09956 07/13/2004

Foreign Applications

JAPAN 2003-199391 07/18/2003

If Required, Foreign Filing License Granted: 06/01/2006

The country code and number of your priority application, to be used for filing abroad under the Paris Convention, is **US10/564,815**

Projected Publication Date: 09/07/2006

Non-Publication Request: No

Early Publication Request: No

Title

Correction Also
On Page 2



~~Assisting work management apparatus for substrate work system and assisting work management program for substrate work system~~

Preliminary Class

029

Managing apparatus for managing assisting work to assist substrate-related-work performing system, and managing program for managing assisting work to assist
PROTECTING YOUR INVENTION OUTSIDE THE UNITED STATES
 Substrate-related-work performing system

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